

ASSIGNMENT

To: Honorable Commissioner of Pa.

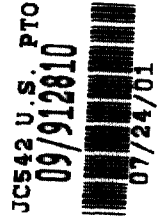
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08-03-2001



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Please record the attached original document or copy thereof.

1. Name of conveying parties:

- a) Chung-Yen Lu
- b) Ruen-rone Lee

2. Name and address of receiving party:

- a) Name: Silicon Integrated Systems Corp.
Address: No. 16, Creation RD. 1, Science-Based Industrial Park
Hsinchu, Taiwan R.O.C.

3. Nature of conveyance

- | | | | |
|-------------------------------------|--------------------|--------------------------|-------------------|
| <input checked="" type="checkbox"/> | Assignment | <input type="checkbox"/> | Merger |
| <input type="checkbox"/> | Security Agreement | <input type="checkbox"/> | Change of Name |
| <input type="checkbox"/> | Other _____ | <input type="checkbox"/> | License Agreement |

Execution Dates: June 11, 2001 and June 8, 2001, respectively.

4. Application Number or Patent Number: Not yet assigned

The title of the new application is: METHOD AND APPARATUS FOR DITHERING AND INVERSELY DITHERING IN IMAGE PROCESSING AND COMPUTER GRAPHICS

5. Please send all correspondence concerning this document to:

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6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41): \$40.00

- ☒ Enclosed
- ☒ Authorized to be charged to Deposit Account No. 50-0805
(Order No. JLINF064)

8. To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.


Date: July 24, 2001

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Attorney Docket No. JLINF064


Albert S. Penilla, Esq.
Registration No. 39,487

(Revised 01/96)

PATENT
REEL: 012027 FRAME: 0281

ASSIGNMENT OF PATENT APPLICATION

Q0787

For good and valuable consideration, receipt of which hereby acknowledged,

I/We,

(a) Chung-Yen LU

(b) Ruen-rone LEE

residing at

(a) 4F, No. 6, Lane 430, Fushing N. Rd., Taipei, Taiwan, R.O.C.

(b) No. 55, Nan Wai Street, Hsin Chu, Taiwan, R.O.C.

assign and transfer to: **Silicon Integrated Systems Corp.**

a corporation organized under the law of Taiwan and having a place of business at :

No. 16, Creation RD. 1, Science-based industrial park, Hsin-chu, Taiwan, R.O.C.

its successors and assigns, my entire right, title and interest, including the right of priority, in, to and under an application for Letters Patent of the United States entitled:

METHOD AND APPARATUS FOR DITHERING AND INVERSELY DITHERING IN IMAGE PROCESSING AND COMPUTER GRAPHICS

including divisions, reissues, continuations and extensions thereof, and all rights of priority without further authorization from me; I agree to execute all papers useful in connection with said United States application, and generally to do everything possible to aid said assignee, its successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in United States; and I request the Commissioner of Patents and Trademarks to issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Joint Inventor (a)	Chung-Yen LU		
Inventor's Signature	<i>Chung-Yen Lu</i>	Date	<i>June 11, 2001</i>
Residence	Taipei	Citizenship	Taiwan, R.O.C.

Joint Inventor (b)	Ruen-rone LEE		
Inventor's Signature	<i>Ruen-Rone Lee</i>	Date	<i>June 8, 2001</i>
Residence	Hsin Chu	Citizenship	Taiwan, R.O.C.